


Search Notes 	Application/Control No. 10573458	Applicant(s)/Patent Under Reexamination OTSUKA ET AL.
	Examiner CHRISTOPHER M ROLAND	Art Unit 2893

SEARCHED			
Class	Subclass	Date	Examiner
257	745, E29.144, E29.149	4 May 2008	CMR
438	571	4 May 2008	CMR
257	11, 14, 200, 201, 471, 473, 615, E33.023, E33.049, E31.019, E29.089, E21.085, E21.173 (text-limited)	4 May 2008	CMR
438	167, 570, 604 (text-limited)	4 May 2008	CMR
257	745, E29.144, E29.149	17 Nov. 2008	CMR
438	571	17 Nov. 2008	CMR
257	11, 14, 200, 201, 471, 473, 615, E33.023, E33.049, E31.019, E29.089, E21.085, E21.173 (text-limited)	17 Nov. 2008	CMR
438	167, 570, 604 (text-limited)	17 Nov. 2008	CMR

SEARCH NOTES		
Search Notes	Date	Examiner
(see EAST search history)	4 May 2008	CMR
Consulted Anh Mai, Primary Examiner, USPTO GAU 2814	6 May 2008	CMR
(see IEEE Xplore search history)	7 May 2008	CMR
(see updated EAST search history)	17 Nov. 2008	CMR
(see IEEE Xplore search history)	18 Nov. 2008	CMR
Consulted Davienne Monbleau, Supervisory Patent Examiner, USPTO GAU 2893	20 Nov. 2008	CMR

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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